



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

-----ooo:O:ooo-----

Application of :  
Toshio KODAMA et al. :  
Appln. No. 10/525,311 : Art Unit - 2881  
Filed: April 18, 2005 : Examiner - Kiet Tuan Nguyen  
For: ION BEAM DEVICE AND ION :  
BEAM PROCESSING METHOD : Docket No. S005-5460 (PCT)

-----ooo:O:ooo-----

MS Amendment  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE**

S I R:

In response to the Office Action mailed October 5, 2006, applicants amend their application as follows:

**ADDITIONAL FEE:**

No additional fee is believed required in connection with this response. However, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

**MAILING CERTIFICATE ON PAGE 13**